

P24336.A05



IAW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Satoshi ABE et al.

Group Art Unit : 1732

Appl. No. : 10/671,688

Examiner : Leo B. TENTONI

Filed : September 29, 2003

Confirmation No. : 7419

For : METHOD OF MAKING THREE-DIMENSIONAL OBJECT

SECOND SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
U.S. Patent and Trademark Office
Customer Service Window, Mail Stop AMENDMENT
Randolph Building
401 Dulany Street
Alexandria, VA 22314

Sir :

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and supplemental to the Information Disclosure Statements filed on May 18, 2004 and April 19, 2004, Applicants hereby submit a copy of a Chinese Office Action dated September 23, 2005, together with an English language translation of the same, with respect to patent family member Chinese Patent Application No. CN 03135965.5, in which the following documents were cited:

- (1) Chinese Patent Publication No. CN 1347783, together with family members U.S. Patent No. 6,657,155, and Japanese Laid-open Patent Publication No. 2002-115004 (corresponding to Patent Application No. 2000-306546).

The Examiner is invited to review the Chinese Office Action to inspect the relevance indicated during Chinese examination with respect to the documents cited therein.

Further to 37 C.F.R. §1.98, a copy of the U.S. patent is not enclosed herewith. However, if a copy is needed, the Examiner is respectfully requested to contact the undersigned.

Applicant respectfully requests that the Examiner consider the above material and cite the same. A copy of Chinese Patent Publication No. CN 1347783 is attached hereto and all of the above-noted documents are listed on the attached PTO-1449 Form. The Examiner is requested to initial the appropriate spaces on the attached PTO-1449 Form and to return a copy of the completed Form to Applicants with the next official communication in the present application.

Further, Applicants note that since this Second Supplemental Information Disclosure Statement is being submitted subsequent to the issuance of an Office Action on the merits, Applicants certify that the Chinese Patent Publication No. CN 1347783 in the Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the Information Disclosure Statement, and thus no fee is required to ensure consideration of the submitted material.


Applicants additionally note that U.S. Patent No. 6,657,155 was previously made of record by the Examiner, and thus, no fee or certification is required to

ensure consideration of this material, as it was already before the Examiner.

Further, Patent Application No. 2000-306546 (corresponding to Japanese Laid-open Patent Publication No. 2002-115004) was previously cited in an Information Disclosure Statement, and thus, no fee or certification is required to ensure consideration of this material, as it was already before the Examiner.

Should the Examiner have any questions, the Examiner is invited to contact the undersigned at the below-listed telephone number.

Respectfully Submitted,
Satoshi ABE et al.



Bruce H. Bernstein
Reg. No. 29,027

Stephen M. Roylance
Reg. No. 31,296

December 8, 2005
GREENBLUM & BERNSTEIN, P.L.C.
1950 Roland Clarke Place
Reston, VA 20191
(703) 716-1191

P24336.P11

Sheet 1 of 1

FORM PTO-1449

U.S. Department of Commerce
Patent and Trademark OfficeAtty. Docket No.
P24336Application No.
10/671,688INFORMATION CLOSURE STATEMENT
BY APPLICANT

(Use several sheets if necessary)

Applicant
Satoshi ABE et al.Filing Date
September 29, 2003Group
1732

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		6 6 5 7 1 5 5	12/02/03	ABE et al.			

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
		1 3 4 7 7 8 3	05/08/02	CHINA			
	2002	- 1 1 5 0 0 4	04/19/02	JAPAN			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DATE CONSIDERED

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.